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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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**PATENT**

In re application of: SARVER et al.

Attorney Docket No.  
NSC1P286/P05740

Application No.: 10/727,188

Examiner: ADAMS, Gregory W.

Filed: December 2, 2003

Group: 3652

Title: METHOD AND APPARATUS FOR  
STACKING SEMICONDUCTOR WAFERS

Confirmation No.: 4986

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**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on April 26, 2006.

Signed: \_\_\_\_\_

Sue Funchess

**AMENDMENT B**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Examiner Adams:

The Applicants' representative thanks you for your input and guidance provided during the brief telephonic discussion of April 24, 2006. This Amendment is filed in response to the Final Office Action dated March 21, 2006. Please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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